

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Cécile AULNETTE et al.

Confirmation No.: 7888

Application No: 10/763,978

Group Art Unit: 2814

Filing Date: January 22, 2004

Examiner: ~~D. Wille~~ Long PHAM.For: SEMICONDUCTOR STRUCTURE FOR
PROVIDING STRAINED CRYSTALLINE LAYER ON
INSULATOR AND METHOD FOR FABRICATING
SAME

Atty. Docket No.: 4717-7300

SUPPLEMENTAL AMENDMENT**Mail Stop AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to a telephone call from the patent office, please enter the following additional amendments and comments into the file of the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.

No fee is believed to be due for this submission. Should any fees be required, please charge them to Winston & Strawn LLP deposit account 16-1150.

Certificate of Facsimile Transmission under 37 CFR § 1.8

I hereby certify that this correspondence, consisting of an nine page amendment, is being transmitted by facsimile to the United States Patent and Trademark Office, to facsimile telephone number 571-273-1714 on October 4, 2005.

for: Julie Shi (Reg. No. 57,073)
Allan A. Fanucci (Reg. No. 30,256)